## IAP15 Rec'd PCT/PTO 03 APR 2006

				Complete if Known 10/57451			
•				Application Number	New Application		
	ATION DISC			Filing Date	April 3, 2006		
STATEM	STATEMENT BY APPLICANT			First Named Inventor	MASSELINK et al		
				Group Art Unit	2815		
				Examiner Name	Ho, Anthony		
				Confirmation No.			
Sheet	1	of	3	Attorney Docket Number	3367-102		

U.S. PATENT DOCUMENTS							
Examiner Cite Initials* No.		U.S. Patent D	ocument  Kind Code <sup>2</sup> (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY		
/A.H./	1.	2002/0136932	. A1	Yoshida	9/26/02		
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/A.H./	3.	2002/0114367	A1	Stintz et al	8/22/02		
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<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>&</sup>lt;sup>1</sup>Unique citation designation number. <sup>2</sup>See attached Kinds of U.S. Patent Documents. <sup>3</sup>Enter Office that issued the document, by the two-letter code. <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.

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				Complete if Known 90/5745			
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	Information disclosure				April 3, 2006		
STATEME	STATEMENT BY APPLICANT			First Named Inventor	MASSELINK et al		
				Group Art Unit	2815		
					Ho, Anthony		
				Confirmation No.			
Sheet	2	of	3	Attorney Docket Number	3367-102		

		NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published					
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				Application Number		New Application					
	MATION DISC		Filing Date		April 3, 2006						
STATEMENT BY APPLICANT				First Named Inventor  Group Art Unit  Examiner Name		MASSELINK et al 2-815 Ho, Anthony					
								Confirmation No.			
								Sheet	Sheet 3 of 3 Attorney		Attorney Docket N
				Examiner Signature	/Anthor	ny Ho/			Date Conside	ered	08/21/2007

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